



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

June 25, 2026	
IGI Report Number	LG813640624
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUT CORNERED RECTANGULAR MODIFIED BRILLIANT
Measurements	13.63 X 9.01 X 5.43 MM

GRADING RESULTS

Carat Weight	6.02 CARATS
Color Grade	F
Clarity Grade	VS 1

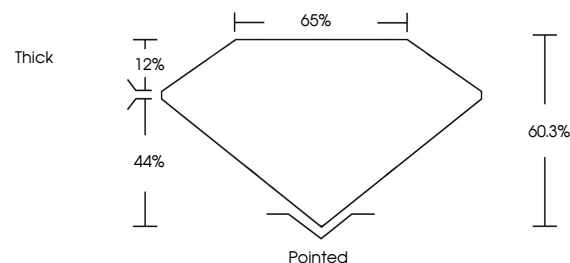
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	131 LG813640624

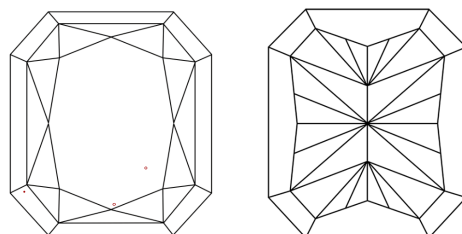
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG813640624
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

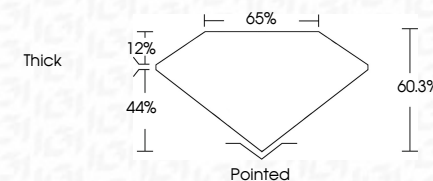
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

June 25, 2026	Carat Weight	Clarity Grade	Culet
G1 Report No. L	Color Grade	Depth	Polish
CUT CORNERED		Table	Symmetry
		Girdle	Fluorescence
			Association(s)

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created by Chemical Vapor Deposition
(CVD) growth process.